

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Sven Antoin Johan HOL, Edwin Johan BUIS, Harmen Klaas VAN DER

SCHOOT, Patricia VREUGDEWATER

Application No.:

10/797,618

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Examiner

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For:

LITHOGRAPHIC ACTUATOR MECHANISM, LITHOGRAPHIC APPARATUS, AND

DEVICE MANUFACTURING METHOD

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SUPPLEMENTAL APPLICATION DATA SHEET 37 C.F.R. § 1.76(c)

BIBLIOGRAPHIC DATA

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